

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DAVID J. BAIN, ET AL.)
) Group Art Unit: 2836
Serial No.:	10/710,653)
)
Filed:	July 27, 2004) Examiner: Roman, L.
)
For:	PRESSURE ASSISTED WAFER)
	HOLDING APPARATUS AND) Confirmation No.: 4652
	CONTROL METHOD)

RESPONSE AFTER FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed August 22, 2007, the Applicants submit the following remarks: